

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	3803	((134/95.2) or (134/105) or (134/107) or (135/135) or (134/137) or (134/158) or (134/902)).CCLS.	USPAT; USOCR	OR	OFF	2007/01/19 13:50
L2	4	l1 and @py>"2006"	USPAT	OR	ON	2007/01/19 13:51
L3	97	l1 and @py>"2005"	USPAT	OR	ON	2007/01/19 13:51
L4	3040	l1 and @pd>"08012006"	USPAT	OR	ON	2007/01/19 13:52
L5	40	l1 and @pd>"20060801"	USPAT	OR	ON	2007/01/19 13:53
S1	457	134/95.2	USPAT	OR	ON	2006/08/16 12:32
S2	3768	((134/95.2) or (134/105) or (134/107) or (135/135) or (134/137) or (134/158) or (134/902)).CCLS.	USPAT; USOCR	OR	OFF	2006/08/16 12:38
S3	263	S2 and gas adj supply	USPAT	OR	ON	2006/08/16 12:38
S4	90	S2 and gas adj supply and liquid adj supply	USPAT	OR	ON	2006/08/16 15:26
S5	1	("5331987").PN.	USPAT; USOCR	OR	OFF	2006/08/16 15:26
S6	3768	((134/95.2) or (134/105) or (134/107) or (135/135) or (134/137) or (134/158) or (134/902)).CCLS.	USPAT; USOCR	OR	OFF	2006/08/17 09:57
S7	21	S6 and translucent	USPAT	OR	ON	2006/08/17 10:04
S8	19	pipe with gas with humidity with adjust\$4	USPAT	OR	ON	2006/08/17 10:09
S9	70	(pipe or line) same gas with humidity with adjust\$4	USPAT	OR	ON	2006/08/17 10:36
S10	0	"bubble suppressing element"	USPAT	OR	ON	2006/08/17 10:36
S11	17	"bubble suppressing"	USPAT	OR	ON	2006/08/17 10:36
S12	3	((("4960141") or ("4643774") or ("4714086")).PN.	USPAT; USOCR	OR	OFF	2006/08/18 10:18
S13	0	"process a substrate" and holder	USPAT	OR	ON	2007/01/16 16:55
S14	1512	clean\$3 adj substrate and (holder carriage arm)	USPAT	OR	ON	2007/01/16 16:56
S15	883	clean\$3 adj substrate and (holder carriage arm) and wafer	USPAT	OR	ON	2007/01/16 16:56
S16	417	clean\$3 adj substrate and rotat\$4 with (holder carriage arm) and wafer	USPAT	OR	ON	2007/01/16 16:57
S17	16	"6158449"	USPAT	OR	ON	2007/01/16 16:59
S18	2	"6394110"	USPAT	OR	ON	2007/01/16 16:59

## EAST Search History

S19	29	"5331987"	USPAT	OR	ON	2007/01/16 17:00
S20	0	"10671817"	US-PGPUB	OR	ON	2007/01/18 17:51
S21	1	"10/671817"	US-PGPUB	OR	ON	2007/01/18 17:51
S22	200	halogen with infrared with radiation with heat\$3	USPAT	OR	ON	2007/01/19 11:31
S23	122	halogen with infrared with radiation with heat\$3 and substrate	USPAT	OR	ON	2007/01/19 11:31
S24	29	halogen with infrared with radiation with heat\$3 and substrate with dry\$3	USPAT	OR	ON	2007/01/19 11:31
S25	40	substrate with clean\$3 and "de-gas"	USPAT	OR	ON	2007/01/19 12:01